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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Y. Ahn et al.

Title: ATOMIC LAYER-DEPOSITED LaAlO₃ FILMS FOR GATE DIELECTRICS

Docket No.: 1303.050US2

Serial No.: 10/789,042

Filed: February 27, 2004

Due Date: July 12, 2006

Examiner: Allan R. Wilson

Group Art Unit: 2815

MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

☒ Return postcard.

☒ Response to Notice of Non-Compliant Amendment (10 pgs.).

If not provided for in a separate paper filed herewith, please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

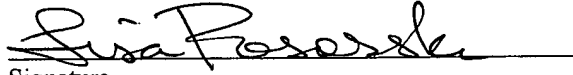
By: 

Atty: David R. Cochran

Reg. No. 46,632

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 7 day of July, 2006.

LISA ROSORSKE
Name


Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)



10/789,042

PATENT

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Applicant:	KIE Y. AHN ET AL.	Examiner:	Allan R. Wilson
Serial No.:	10/789,042	Group Art Unit:	2815
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RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This responds to the Notice of Non-Compliant Amendment mailed on June 12, 2006. In compliance with 37 CFR 1.121, Applicant submits the following corrected section from Applicants' previously-submitted Amendment and Response filed May 23, 2006.